

AMENDMENT TRANSMITTAL LETTER

Docket Number

KRM-00101

Application Number

10/080,848

Filing Date

February 22, 2002

Examiner

DEO, Duy Vu Nguyen

Group Art Unit

1765

Invention Title

METHOD AND MANUFACTURING A SEMICONDUCTOR DEVICE CAPABLE OF ETCHING A MULTI-LAYER OF ORGANIC FILMS AT A HIGH SELECTIVITY

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application, including:

- (X) Amendment and Response;
(X) Priority Document; and
(X) Postcard Receipt

CLAIMS AS AMENDED

(1)

(2)

(3)

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT NUMBER EXTRA	RATE	FEE
TOTAL CLAIMS	16	Minus	29	0	X \$50	\$0
INDEPENDENT CLAIMS	4	Minus	10	0	x \$200	\$0
MULTIPLE DEPENDENT CLAIM ADDED					\$360	
					TOTAL	\$0
If applicant has small entity status under 37 CFR 1.9 and 1.27, then divide total fee by 2, and enter amount here.				SMALL ENTITY TOTAL		\$

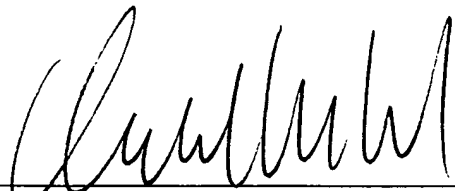
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Donald W. Muirhead, Reg. No. 33,978

December 21, 2004

Date

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Alison L. Barnett



AF/IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Hiroto OHTAKE et al. :
 :
 :
Appl. No.: 10/080,848 : Art Unit: 1765
 :
 :
Filed: February 22, 2002 : Examiner: DEO, Duy Vu Nguyen
 :
 :
For: METHOD OF MANUFACTURING A : Atty Docket: KRM-00101
SEMICONDUCTOR DEVICE :
CAPABLE OF ETCHING A MULTI- :
LAYER OF ORGANIC FILMS AT A :
HIGH SELECTIVITY :

CERTIFICATE OF MAILING

I hereby certify that the foregoing document is being deposited with the United States Postal Service as first class mail, postage prepaid, "Post Office to Addressee", in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 21, 2004.

Alison L. Barnett
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AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is being provided in response to the Final Office Action dated October 7, 2004, for the above-captioned U.S. patent application.

Amendments to the Claims are listed beginning on page 2 of this paper.

Remarks begin on page 8 of this paper.

It is not believed that extensions of time or fees for net addition of claims are required, beyond those which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required for consideration of this paper (including fees for net addition of claims) are authorized to be charged in two originally-executed copies of an Amendment Transmittal Letter filed herewith.